



VERSION WITH MARKINGS TO SHOW CHANGES MADE

In the Specification:

PRIORITY APPLICATION

RECEIVED
NOV 20 2002
RC 2800 MAIL ROOM

This patent application claims benefit under 35 U.S.C. 119(e) of the United States Provisional application number 60/340,554 filed on December 14, 2001, entitled: "SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF."

CO-PENDING APPLICATIONS

This application is related to United States Patent Application Serial No. 10/058,852 entitled "SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF", filed on January 28, 2002, and having Attorney Docket Number 1458.TT4773; and United States Patent Application Serial No. 10/058,854 entitled "SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF" filed on January 28, 2002, and having Attorney Docket Number 1458.TT4962.